



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2823
Examiner: Fernando L. Toledo

In Re PATENT APPLICATION of:

Applicant(s): Masaru TAKAISHI

Serial No.: 10/766,212

Filing Date: January 29, 2004

For: METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE

Atty. Ref.: AI 325

)
)
)
)
) **REQUEST FOR**
) **RECONSIDERATION**
)
)
)

October 26, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Reconsideration of the rejections presented in the Examiner's Action
mailed on June 30, 2006 is requested for the following reasons: